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PAGE 1/7 * RCV'D AT 6/27/2005 11:45:44 AM [Eastern Daylight Time] * SVR:USPTO-EFXRF-1/0 * DNIS:8729306 * CSID:5109233360 * DURATION (mm:ss):01-18

Reference:
Application No.: 10723,046
Filing date: 11/26/2003

Art. Unit: 2811
Applicant: Hui Peng

Title: Textures of Substrates and a Method for Minimizing Effects of Lattice Mismatch
Examiner/Art Unit: Shanching Hu/2811

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Fremont, CA, June 27, 2005

[AMENDMENT]

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22311-1450

Sir:

This letter responds to the Office Action Summary dated May 24, 2005 and mailed to applicant on 5/31/2005. Please amend the above patent application as the following.

TITLE: replace with following new title:
"Texture for Localizing and Minimizing Effects of Lattice Constants Mismatch."

SPECIFICATION: There is no amendment to the specification.

CLAIMS: Amendent to the claims of the above patent application begin on page 1 of this amendment.

DRAWINGS: There is no amendment to the drawings.

REMARKS: Remarks begin on page 5 of this amendment.